

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Züger
SERIAL NO.: 10/530,994 GROUP NO.: 2823
FILING DATE: April 12, 2005 EXAMINER: W. David Coleman
TITLE: A Method For The Production Of A Substrate With A Magnetron
 Sputter Coating And Equipment For The Same

Commissioner for Patents
P.O. Box 1450
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PRELIMINARY AMENDMENT AND RESPONSE FOR RCE

The Applicant requests entry of this Preliminary Amendment and Response for RCE. The following remarks are responsive to the Office Action mailed on August 6, 2007 in the above-identified patent application. Consideration of the following remarks, and allowance of the claims, as presented, is respectfully requested. A Petition for a two-month extension of time, up to and including January 6, 2008 is submitted herewith. Authorization to charge Attorney's charge card for the extension fee and any other proper fees is given in the EFS-Web filing submission papers.

Amendments to the claims begin on page 2 of this paper.

Remarks are on page 8 of this paper.